

**REPLY UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER 2800**

Attorney's Docket No. 042390.P5771D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Gang Bai and Chunlin Liang

Application No. 09/517,705

Filed: March 2, 2000

For: *Complementary Metal Gate Electrode  
Technology*

Examiner: Loke, Steven Ho Yin

Art Unit: 2811

SUPPLEMENTAL AMENDMENT AND RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Dear Sir:

In response to the Advisory Action mailed May 1, 2006, Applicants respectfully request entry of the following Supplemental Amendment.